



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 16, 2025

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG756598048

LABORATORY GROWN DIAMOND

CUT CORNERED RECTANGULAR
MODIFIED BRILLIANT

10.23 X 7.05 X 4.78 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

3.01 CARATS

E

VS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

Inscription(s)

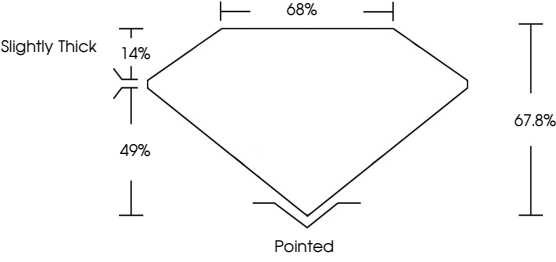
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



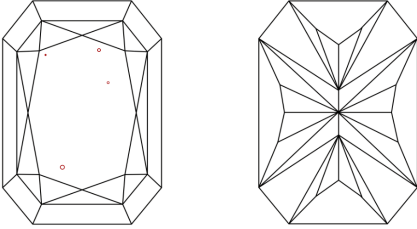
LG756598048

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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CUT CORNERED RECT. MODIFIED BRILLIANT

10.23 X 7.05 X 4.78 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Slightly Thick

Culet

Polish

Symmetry

Fluorescence

Inscription(s)

3.01 CARATS

E

VS 2

67.8%

68%

Slightly Thick

Pointed

EXCELLENT

EXCELLENT

NONE



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